

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:) **CONFIRMATION NO.: 1461**
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Yasuhiko KOJIMA, et al.)
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U.S. Serial No.: 10/591,476) Group Art Unit: 1715
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Filed: September 1, 2006) Examiner: Mandy C. Louie
)
For: COPPER FILM DEPOSITION METHOD

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in reply to the Office Action mailed July 12, 2011, to which the time for response was set to expire October 12, 2011. A Petition for Extension of Time for one month and the requisite fee are submitted herewith to extend the date for reply to November 12, 2011.

Therefore, please accept this Response as timely filed.

Kindly amend the above-identified patent application as set forth below.